



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Raulf M. Polichar, et al.

Application No.: 09/736,157

Examiner: KIN CHAN CHEN

Filed: December 15, 2000

Group Art Unit: 1765

Atty. Docket No.: SAIC0010-US

For: PIN ALLOY-SEMICONDUCTOR, RADIATION DETECTORS WITH RECTIFYING JUNCTION CONTACTS, METHODS AND SYSTEMS FOR FORMING PIN ALLOY-SEMICONDUCTOR DEVICES WITH RECTIFYING JUNCTION CONTACTS, AND SYSTEMS AND METHODS FOR ANALYZING ALLOY-SEMICONDUCTOR PROPERTIES

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
Washington, DC 20231

Dear Sir:

In response to the Office Action dated May 6, 2002, Applicants respectfully request entry of the following remarks into the file of the above identified application.

REMARKS

On page 2 of the Office Action, a restriction requirement pursuant to 35 U.S.C. § 121 was imposed on the pending claims requesting election of one of the following groups for purposes of examination:

- I. Claims 1 - 12, drawn to a method, classified in Class 438, subclass 708; and
- II. Claims 13 - 24, drawn to a product device, classified in Class 250, subclass

370.

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